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JAP9 Rec'd PCT/PTO 07 FEB 2006

## IN THE U.S. PATENT AND TRADEMARK OFFICE

February 7, 2006

Applicant : Mikio SUGIMOTO  
For : MANUFACTURING METHOD OF METAL ION WATER,  
WATER TREATMENT METHOD USING THE MANUFACTURING  
METHOD, MANUFACTURING DEVICE OF METAL ION WATER,  
AND WATER TREATMENT APPARATUS USING THE  
MANUFACTURING DEVICE

PCT International Application No.: PCT/JP2004/011721

PCT International Filing Date: August 9, 2004

U.S. Application No.

(if known, see 37 CFR 1.5): Unknown

Atty. Docket No.: 4900.P0056US


Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(1) and 1.98, enclosed herewith is a copy of the International Search Report, Form PTO-1449 and the references cited thereon. The relevance of these references is explained on the enclosed search report. Accordingly, further comment at this point in time should not be necessary.

Respectfully submitted,

  
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Encl: Copy of International Search Report  
Form PTO-1449 and one copy of each reference listed  
thereon

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INFORMATION  
DISCLOSURE  
CITATION

Applicant: Mikio SUGIMOTO

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## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AG	JP 10-323671	12-08-1998	MITSUMOTO et al	Abstract
	AH	JP 9-253627	09-30-1997	NISHIBORI et al	Abstract
	AI	JP 2000-24675	01-25-2000	OTSUKA	Abstract
	AJ	JP 11-192492	07-21-1999	SOENO	Abstract
	AK	JP 62-258791	11-11-1987	JIYATSUKU	Abstract
	AL	JP 11-156367	06-15-1999	SHINAGAWA	Abstract
	AM	JP 59-70457	04-20-1984	SATOU et al	Abstract
	AN	JP 6-206804	07-26-1994	MOTOMURA et al	Abstract

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AO	
	AP	
EXAMINER SIGNATURE		DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.